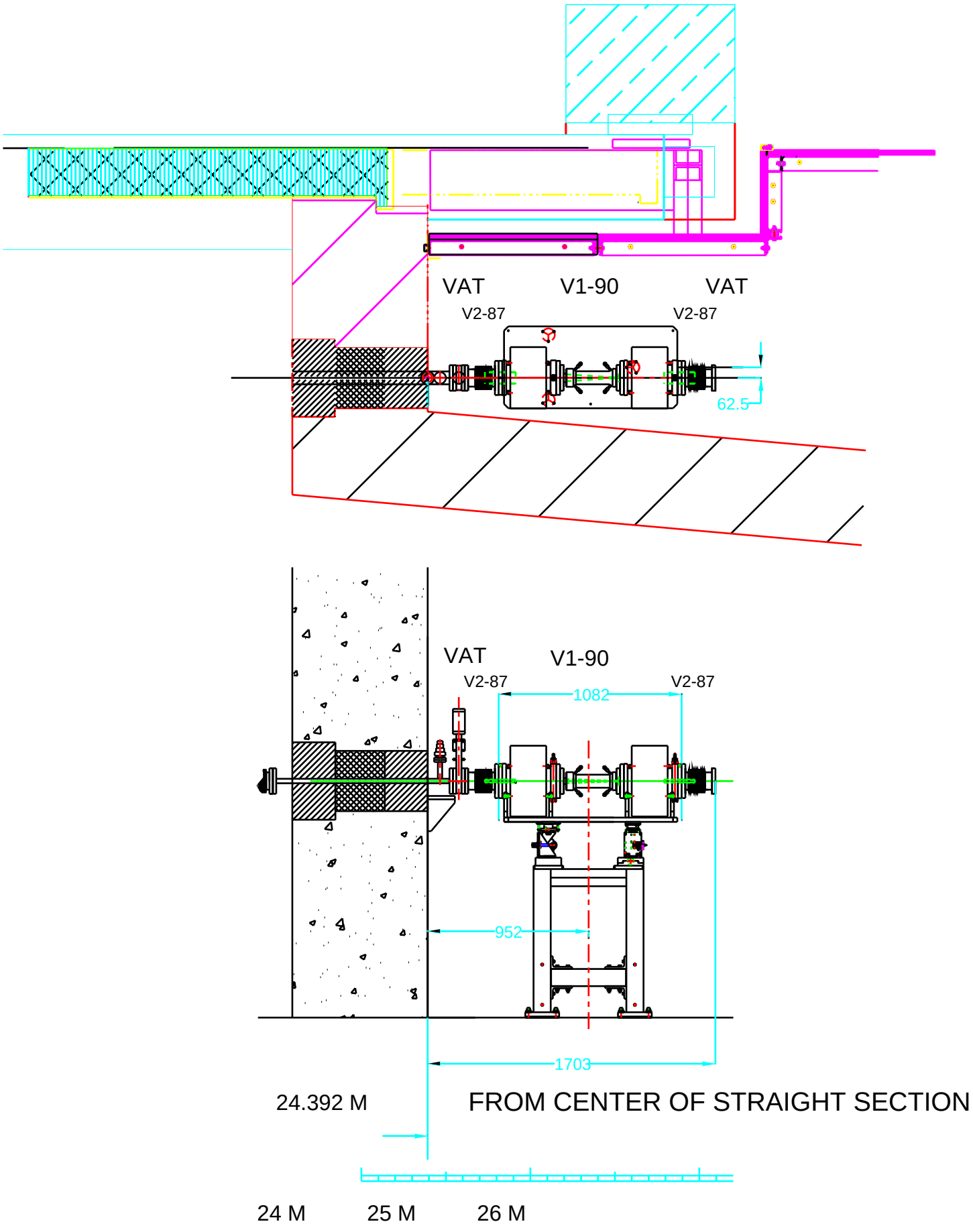

V1-90 APS DIFFERENTIAL PUMPING SYSTEM
FOR UNDULATOR ONLY BEAMLINES with FIXED MASK L5-83
9/6/96 (Rev.-01)